

Fractomechanoluminescence Produced During Impulsive Deformation of III-V Semiconductor

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ABSTRACT

When III-V semiconductor fractured impulsively by the impact of a moving piston, then initially the ML intensity increases linearly with time, attains a pick value I_m at a particular time t_m , and later on it decreases with time. The value of time t_m decreases with increasing value of impact velocity, in which t_m is proportional to logarithm of the inverse of v_o , the value of I_m increases linearly with v_o , and the value of I_T initially increases linearly with v_o and then it attains a saturation value for higher value of v_o . The values of t_m increases with the logarithm of the thickness of crystals and the value of the I_m increases linearly with the area of cross section of the crystals and the value of I_T increases linearly with the volume of the crystals.

Keywords: Fractomechanoluminescence, III-V Semiconductor.

INTRODUCTION

To date, the mechanisms of ML in elemental and III-V semiconductors have not been studied in detail. For the ML excitation in elemental and III-V semiconductors, the following models may be proposed: (i) charging of newly created surfaces, (ii) thermal generation of charge carriers. (iii) recombination of fracture-generated defects, and (iv) formation of crack-induced localized states.

Theory

The rate of generations g_1 , g_2 and g_3 , of electrons in the conduction band, may be expressed as

$$g_1 = z_1 \frac{dS}{dt} \quad (1)$$

$$g_2 = z_2 \frac{dS}{dt} \quad (2)$$

$$g_3 = z_3 \frac{dS}{dt} \quad (3)$$

The rate of creation of new surfaces is given by (Chandra *et al.* 2012)

$$\frac{dS}{dt} = bZ_0V^{(m+m')}K_0 (n + n' - n'') \frac{v_0}{H} \exp[-\{(\xi + \gamma)t\}] \left[\frac{v_0}{H\xi} \{1 - \exp(-\xi t)\} \right]^{n+n'-n''-1} \quad (4)$$

Eqs. (1), (2) and (3) can be expressed as:

$$g_1 = z_1bz_0V^{m+m'}K_0 (n + n' - n'') \frac{v_0}{H} \exp\{-(\xi + \gamma)t\} \left[\frac{v_0}{H\xi} \{1 - \exp(-\xi t)\} \right]^{n+n'-n''-1} \quad (5)$$

$$g_2 = z_2bz_0V^{m+m'}K_0 (n + n' - n'') \frac{v_0}{H} \exp\{-(\xi + \gamma)t\} \left[\frac{v_0}{H\xi} \{1 - \exp(-\xi t)\} \right]^{n+n'-n''-1} \quad (6)$$

$$g_3 = z_3bz_0V^{m+m'}K_0 (n + n' - n'') \frac{v_0}{H} \exp\{-(\xi + \gamma)t\} \left[\frac{v_0}{H\xi} \{1 - \exp(-\xi t)\} \right]^{n+n'-n''-1} \quad (7)$$

where

b = a constant, Z_0 = proportionality constant, V = volume of crystals

m = an exponent, m' = an exponent, K_0 = a constant, n = an exponent

n' = an exponent, n'' = an exponent, v_0 = initial velocity of piston

H = thickness of the sample,

$\xi = \frac{1}{\tau_r}$ = rate-constant for the relaxation of moving piston

τ_r = time constant for the relaxation of moving piston

and, γ = rate constant for the decrease of average surface area produced by the movement of single crack

If ϕ_1 , ϕ_2 and ϕ_3 are the rate constants for the recombination of the electrons then we can written as

$$\frac{d\Delta n_1}{dt} = g_1 - \phi_1\Delta n_1 \quad (8)$$

$$\frac{d\Delta n_2}{dt} = g_2 - \phi_2\Delta n_2 \quad (9)$$

$$\frac{d\Delta n_3}{dt} = g_3 - \phi_3\Delta n_3 \quad (10)$$

where Δn_1 , Δn_2 and Δn_3 are the changes in the number of electrons in the conduction

band and shallow traps, surface states and defect centres an any time t .

$$\frac{d\Delta n_1}{dt} = \frac{z_1bz_0VK_0v_0}{H} \exp\{-\xi t\} - \phi_1\Delta n_1 \quad (11)$$

$$\frac{d\Delta n_2}{dt} = \frac{z_2bz_0VK_0v_0}{H} \exp\{-\xi t\} - \phi_2\Delta n_2 \quad (12)$$

$$\frac{d\Delta n_3}{dt} = \frac{z_3bz_0VK_0v_0}{H} \exp\{-\xi t\} - \phi_3\Delta n_3 \quad (13)$$

If η'_1 , η'_2 and η'_3 are the efficiency for the electron-hole radiative recombination for the signals A, B, and C.

$$I_1 = \eta'_1\phi_1\Delta n_1 = \frac{\eta'_1z_1bz_0VK_0v_0}{H(\phi_1-\xi)} \phi_1 [\exp(-\xi t) - \exp(-\phi_1 t)] \quad (14)$$

$$I_2 = \eta'_2\phi_2\Delta n_2 = \frac{\eta'_2z_2bz_0VK_0v_0}{H(\phi_2-\xi)} \phi_2 [\exp(-\xi t) - \exp(-\phi_2 t)] \quad (15)$$

$$\text{and, } I_3 = \eta'_3\phi_3\Delta n_3 = \frac{\eta'_3z_3bz_0VK_0v_0}{H(\phi_3-\xi)} \phi_3 [\exp(-\xi t) - \exp(-\phi_3 t)] \quad (16)$$

For $\phi_1 \gg \xi$, $\phi_2 \gg \xi$ and $\phi_3 \gg \xi$ Eqs. (14), (15) and (16) can be expressed as

$$I_{1r} = \frac{\eta'_1z_1bz_0VK_0v_0\phi_1 t}{H} \quad (17)$$

$$I_{2r} = \frac{\eta'_2 z_2 b z_0 V K_0 v_0 \phi_2 t}{H} \quad (18)$$

$$I_{3r} = \frac{\eta'_3 z_3 b z_0 V K_0 v_0 \phi_3 t}{H} \quad (19)$$

It is evident from Eqs. (17), (18) and (19) that after the fracture I_{1r} , I_{2r} and I_{3r} should increase linearly with time t .

The ML intensity I_m corresponding to the peak of ML intensity versus time curve can be given by

$$I_{m1} = \frac{\eta'_1 z_1 b z_0 V K_0 v_0}{H} \quad (20)$$

$$I_T = \frac{b z_0 V K_0 v_0}{H} \int_0^\infty \left[\frac{\eta'_1 z_1 \phi_1}{(\phi_1 - \xi)} [\exp(-\xi t) - \exp(-\phi_1 t)] + \frac{\eta'_2 z_2 \phi_2}{(\phi_2 - \xi)} [\exp(-\xi t) - \exp(-\phi_2 t)] + \frac{\eta'_3 z_3 \phi_3}{(\phi_3 - \xi)} [\exp(-\xi t) - \exp(-\phi_3 t)] \right] dt$$

$$I_T = (\eta'_1 z_1 + \eta'_2 z_2 + \eta'_3 z_3) \frac{b z_0 V K_0 v_0}{H \xi} \quad (26)$$

where ξ is given by

$$\xi = \frac{v_0}{H[1 - \exp(-\delta v_0)]} \quad (27)$$

To date, no experimental studies have been made on the impulsive excitation of ML in elemental and III-V semiconductors.

CONCLUSION

When a III-V semiconductors is fractured impulsively by the impact of a moving piston, then initially the ML intensity increases linearly with time, attains a peak value I_m at a particular time t_m , and later on it decreases with time. The value of time t_m decreases with increasing value of the impact velocity, in which t_m is proportional to logarithm of the inverse of

$$I_{m2} = \frac{\eta'_2 z_2 b z_0 V K_0 v_0}{H} \quad (21)$$

$$I_{m3} = \frac{\eta'_3 z_3 b z_0 V K_0 v_0}{H} \quad (22)$$

The decay of ML intensity may be expressed as

$$I_{1d} = \eta'_1 \phi_1 \Delta n_1 = I_{m1} \exp[-\phi_1(t - t_m)] \quad (23)$$

$$I_{2d} = \eta'_2 \phi_2 \Delta n_2 = I_{m2} \exp[-\phi_2(t - t_m)] \quad (24)$$

$$I_{3d} = \eta'_3 \phi_3 \Delta n_3 = I_{m3} \exp[-\phi_3(t - t_m)] \quad (25)$$

The ML intensity versus time curve can be expressed as

v_0 , the value of I_m increases linearly with v_0 , and the value of I_T initially increases linearly with v_0 and then it attains a saturation value for higher values of v_0 . The values of t_m increases with the logarithm of the thickness of crystals and the value of I_m increases linearly with the area of cross-section of the crystals and the value of I_T increases linearly with the volume of the crystals. To date, no experimental studies have been made on the impulsive excitation of ML in elemental and III-V semiconductors.

REFERENCE

1. Chandra, B.P., Chandra, V.K., Jha, P., Patel, Rashmi, Shende, S.K., Thaker, S., Baghel, R.N., *J. Lumin.* 132, 2012-2022 (2012).